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AMENDMENT UNDER 37 C.F.R. §1.116  
EXPEDITED PROSECUTION - GROUP ART UNIT 1771

03500.014776

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
HIROKATSU MIYATA ) Examiner: Hai Vo  
Application No.: 09/657,616 ) Group Art Unit: 1771  
Filed: September 8, 2000 )  
For: MESOSTRUCTURED THIN FILM, )  
MESOPOROUS THIN FILM, AND )  
PROCESS FOR PRODUCTION )  
THEREOF ) March 24, 2003

#13/B(Ne)  
60  
4203

Commissioner for Patents  
Washington, D.C. 20231  
Box: AF

RESPONSE AFTER FINAL REJECTION

Sir:

In response to the final Office Action dated December 24, 2002, kindly  
consider the remarks which follow:

I hereby certify that this correspondence is being deposited with the  
United States Postal Service as first-class mail in an envelope addressed  
to: Commissioner for Patents, Washington, D.C. 20231 on

March 24, 2003

(Date of Deposit)

PETER SAXON (24947)

(Name of Attorney for Applicant)

*Peter Saxon*

Signature

March 24, 2003

Date of Signature